

**Resolution Enhancement Techniques In Optical Lithography  
(SPIE Tutorial Texts In Optical Engineering Vol. TT47)  
[Paperback] [2001] (Author) Alfred Kwok-Kit Wong**

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We survey the history of resolution enhancement techniques the exciting modern developments that provide resolution enhancement techniques in optical microscopy.

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forcing semiconductor manufacturers to extend the current 193 nm optical lithography systems The combined techniques include Resolution Enhancement

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Optical proximity correction (OPC) methods are resolution enhancement techniques used extensively in the semiconductor industry to improve the resolution and pattern

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Resolution enhancement techniques (RETs) have, therefore, Resolution enhancement techniques for optical lithography and optical imaging theory Journal

With the adoption of various combinations of resolution enhancement techniques (RET) for IC lithography, different process constraints are placed on the IC layout.

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